## **AMENDMENTS TO THE CLAIMS:**

This listing of claims will replace all prior versions, and listings, of claims in the application:

## **LISTING OF CLAIMS:**

- 1-9. (Cancelled)
- 10. (New) A magnetoresistive layer system, in an environment of a magnetoresistive layer stack that works substantially on the basis of one of a GMR effect and an AMR effect, the system comprising:

a layer array for generating a magnetic field which acts upon the magnetoresistive layer stack, the layer array including at least one hard magnetic layer and at least one soft magnetic layer.

- 11. (New) The magnetoresistive layer system according to claim 10, wherein the hard magnetic layer and the soft magnetic layer are ferromagnetically exchange coupled.
- 12. (New) The magnetoresistive layer system according to claim 10, wherein the layer array is situated at least one of (a) on, (b) below, and (c) next to the layer stack.
- 13. (New) The magnetoresistive layer system according to claim 10, wherein the layer array has a plurality of soft magnetic layers and a plurality of hard magnetic layers, which are combined into layer pairs having a hard magnetic layer and an adjacent soft magnetic layer.
- 14. (New) The magnetoresistive layer system according to claim 10, wherein the soft magnetic layer is composed of a CoFe alloy, Co, Fe, Ni, an FeNi alloy, and magnetic alloys which contain these materials.
- 15. (New) The magnetoresistive layer system according to claim 10, wherein the soft magnetic layer has a thickness between 1 nm and 50 nm.

- 16. (New) The magnetoresistive layer system according to claim 15, wherein the thickness is between 1 nm and 10nm.
- 17. (New) The magnetoresistive layer system according to claim 10, wherein the hard magnetic layer is composed of one of a CoCrPt alloy, a CoSm alloy, a CoCr alloy, a CoCrt alloy, a CoCrt alloy, a CoPt alloy, and an FePt alloy.
- 18. (New) The magnetoresistive layer system according to claim 10, wherein a thickness of the hard magnetic layer is between 20 nm and 100 nm.
- 19. (New) A sensor element comprising a magnetoresistive layer system, in an environment of a magnetoresistive layer stack that works substantially on the basis of one of a GMR effect and an AMR effect, the magnetoresistive layer system including:
- a layer array for generating a magnetic field which acts upon the magnetoresistive layer stack, the layer array including at least one hard magnetic layer and at least one soft magnetic layer.
- 20. (New) The sensor element according to claim 19, wherein the sensor element is for detecting magnetic fields with respect to at least one of strength and direction.